



In The United States Patent & Trademark Office

5 Applicant : Martin E. Kordesch, et al.)
Serial No. : 09/682,151)
10 Filed : 27 July 2001) Examiner: Jerome
Jackson, Jr.
For : CONTACT METHOD FOR THIN) Art Unit:
SILICON CARBIDE EPITAXIAL) 2815
15 LAYER AND SEMICONDUCTOR)
DEVICES FORMED BY THOSE)
METHODS)
_____)

20 AMENDMENT

Commissioner for Patents
Mail Stop: Amendment
P. O. Box 1450
25 Alexandria, VA 22313-1450

Dear Sir:

30 In response to the Office Action mailed June 10, 2005, please amend the
application as follows.